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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tongbi Jiang et al.

Serial No.: 10/689,471

Filed: October 20, 2003

For: A Method For Forming A Stencil
(As Amended)

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Art Unit: 3729

Examiner: Minh N. Trinh

Docket: MCT.0015C2US
97-0524.04US

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed November 8, 2004, please amend the above-referenced patent application as follows:

Date of Deposit: December 8, 2004

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as **first class mail** with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden
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